

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Applicant(s):** William G. America, et al.

**Examiner:** Jack S. J. Chen

**Serial No:** 10/674,646

**Art Unit:** 2813

**Filed:** September 30, 2003

**Docket:** YOR920030320US1 (16868)

**For:** PLASMA SURFACE MODIFICATION  
AND PASSIVATION OF ORGANO-  
SILICATE GLASS FILMS FOR  
IMPROVED HARDMASK ADHESION  
AND OPTIMAL RIE PROCESSING

**Dated:** January 18, 2007

**Confirmation No.** 4797

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE UNDER 37 C.F.R. § 1.121**

Sir:

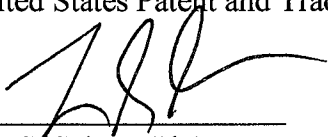
In response to the Office Action dated October 18, 2006, and in accordance with the provisions of 37 C.F.R. §1.121, Applicants submit the following amendment for entry in the above-identified case.

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**CERTIFICATE OF ELECTRONIC FILING**

I hereby certify that this correspondence is being deposited with the United States Patent & Trademark Office via Electronic Filing through the United States Patent and Trademark Office e-business website.

Dated: January 18, 2007

  
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Leslie S. Szivos, Ph.D.